

PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
GROUP ART UNIT 2814**

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Rao, S.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki ABE et al.

Application No.: 08/930,449

Filed: September 30, 1997

Group Art Unit: 2814

Examiner: S. Rao

Docket No.: JAO 39514

For: HIGH ENERGY SUPPLY APPARATUS, METHOD OF
FORMING CRYSTALLINE FILM AND METHOD OF
MANUFACTURING THIN FILM ELECTRONIC DEVICE

REQUEST FOR RECONSIDERATION AFTER FINAL REJECTION

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

In response to the final Office Action mailed April 11, 2000, Applicants respectfully request reconsideration and allowance in view of the following remarks.

Claims 1, 2 and 4-63 are pending. Claims 19, 24, 29, 34, 39, 44, 45 and 50-55 have been withdrawn from consideration.

Rejections Under 35 U.S.C. §103

1. The Office Action rejects claims 1, 2, 4-18, 20-23, 25-28, 30-33, 35-38, 40-43 and 63 under 35 U.S.C. §103(a) over Zhang et al. (U.S. Patent No. 5,403,772) in view of Nakamura (U.S. Patent No. 5,200,630). Applicants respectfully traverse this rejection.

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